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JVE Journal of Vibroengineering

Aims and Scope

Original papers containing developments in vibroengineering of dynamical systems (including mechanical, mechatronic, MEMS, nanotechnology, biomechanics and etc. systems).

The following subjects are principal topics:

- Vibration and wave processes;
- Vibration and wave technologies;
- Nonlinear vibrations;
- Generation of vibrations and waves;
- Vibrostabilization and motion control;
- Transformation of motion by vibrations and waves;
- Dynamics of intelligent mechanical systems;
- Vibration measurements, parameter identification and monitoring.

All published papers are peer reviewed.

General Requirements

The authors must ensure that the paper presents an original unpublished work which is not under consideration for publication elsewhere.

The following structure of the manuscript is recommended: abstract, keywords, nomenclature, introduction, main text, results, conclusions and references. Manuscript should be single-spaced, one column 175 x 248 mm format, using MS Word. Margins: top 13 mm, bottom 17 mm, left 26 mm, right 13 mm, header 8 mm, footer 13 mm.

Font: Times New Roman. Title of the article 16 pt Bold, authors name 10 pt Bold, title of the institution 9 pt Normal, headings of the tables 9 pt Normal, formulas and text 10 pt Normal, indexes 5 pt Normal, all symbols Italic, vectors Bold, numbers Normal. Figures, tables and equations should fit into one column.

The authors are recommended to see the recent issue of the journal and prepare the manuscript in the due style. The authors are responsible for the correctness of the English language.

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Journal of Vibroengineering (JVE) (Quarterly) is published by the company Vibromechanika and is supported by the Lithuanian Academy of Sciences, Kaunas University of Technology, Vilnius Gediminas Technical University and Riga Technical University.

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